

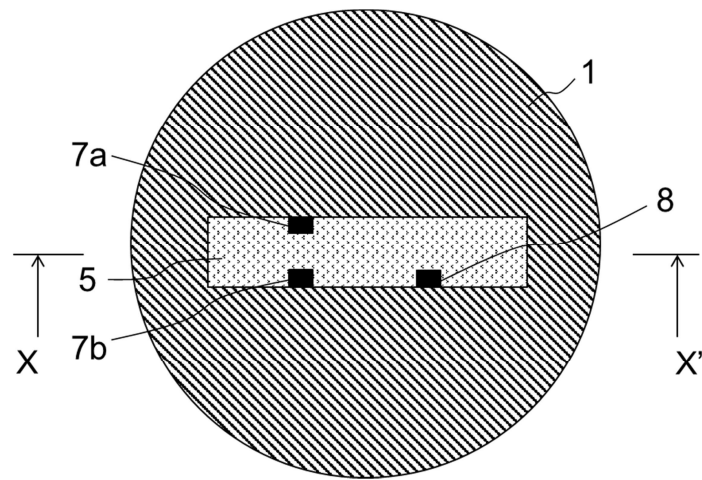


Fig. 1 (a)

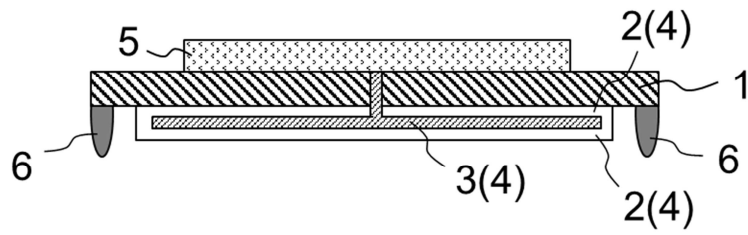


Fig. 1 (b)

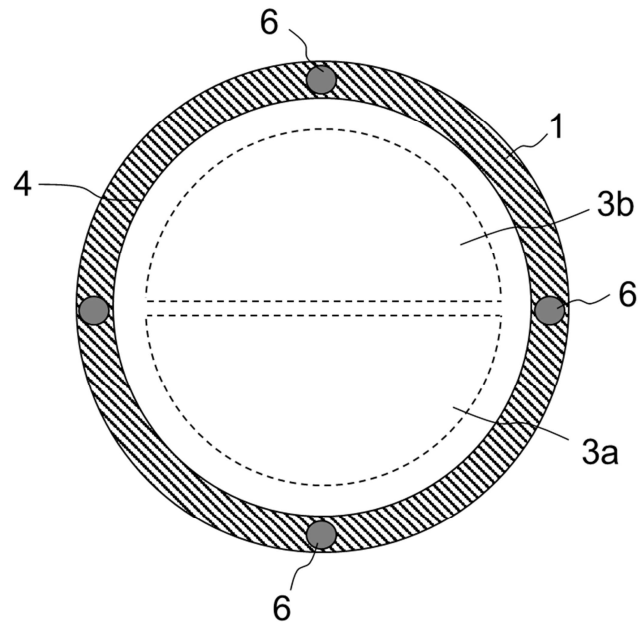


Fig. 1(c)

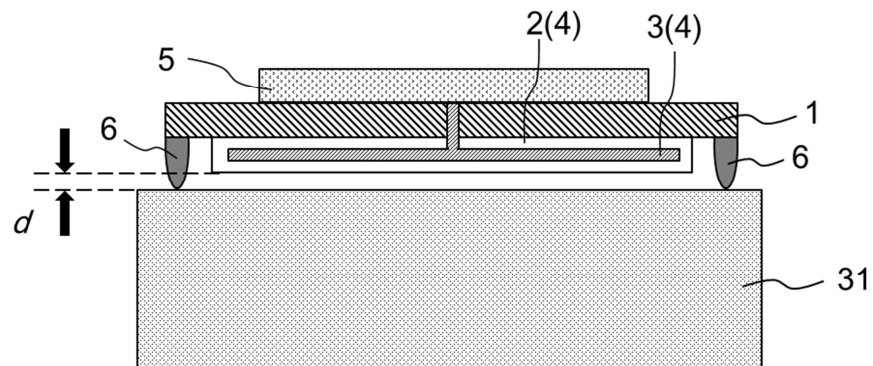


Fig. 2

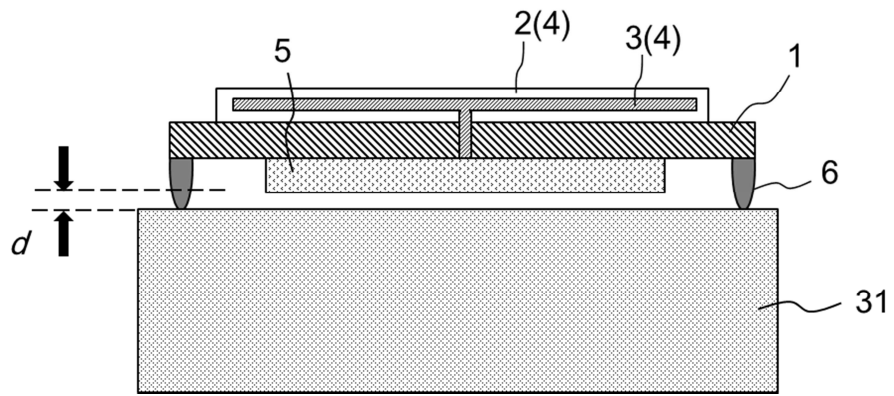


Fig. 3

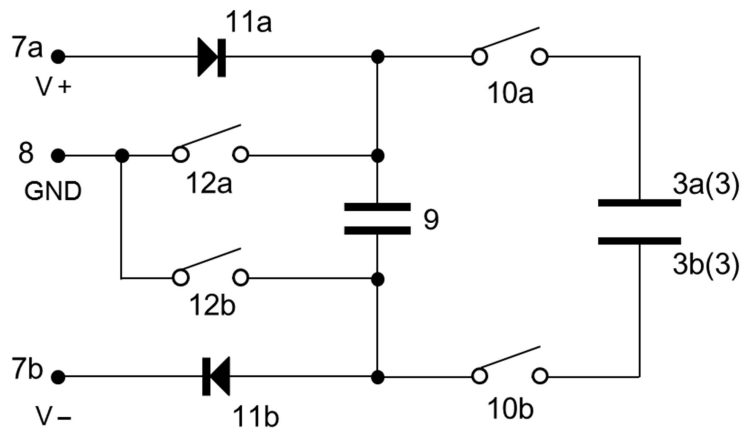


Fig. 4

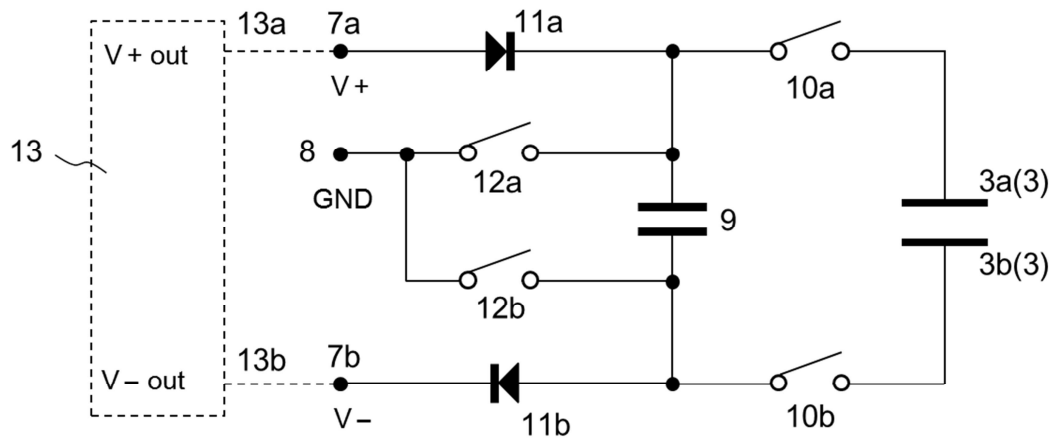


Fig. 5

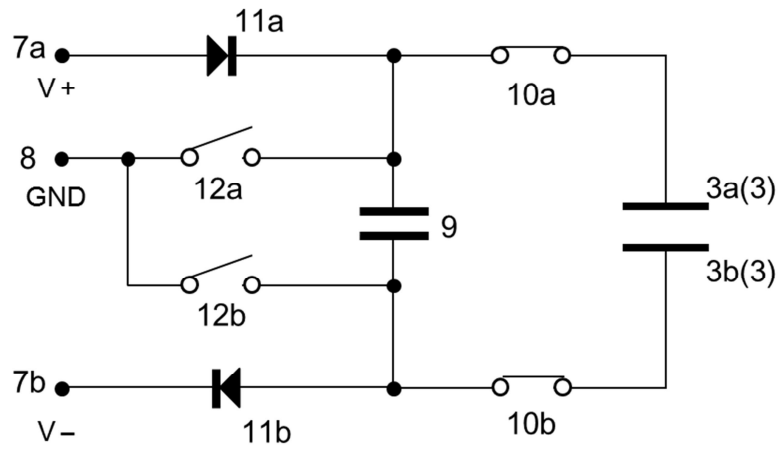


Fig. 6

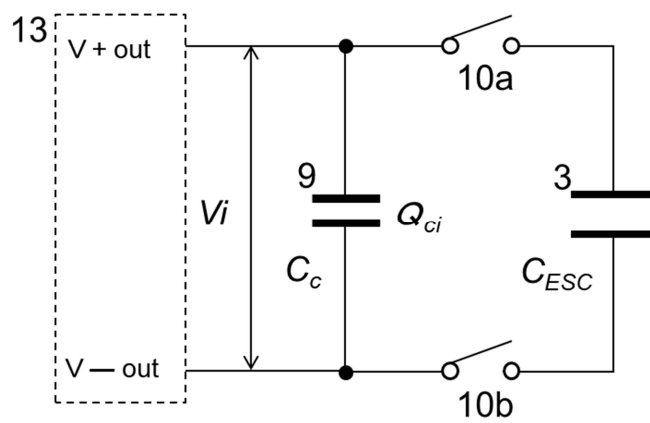


Fig. 7(a)

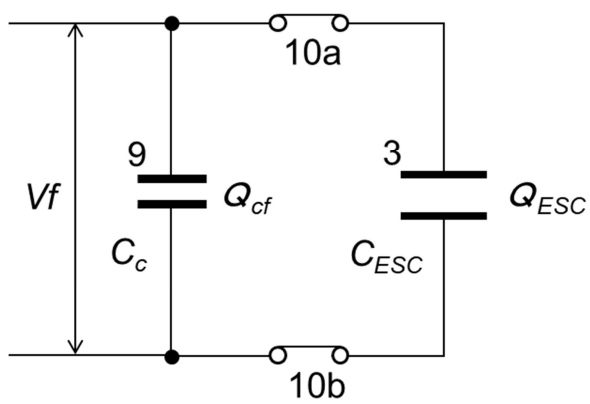


Fig. 7(b)

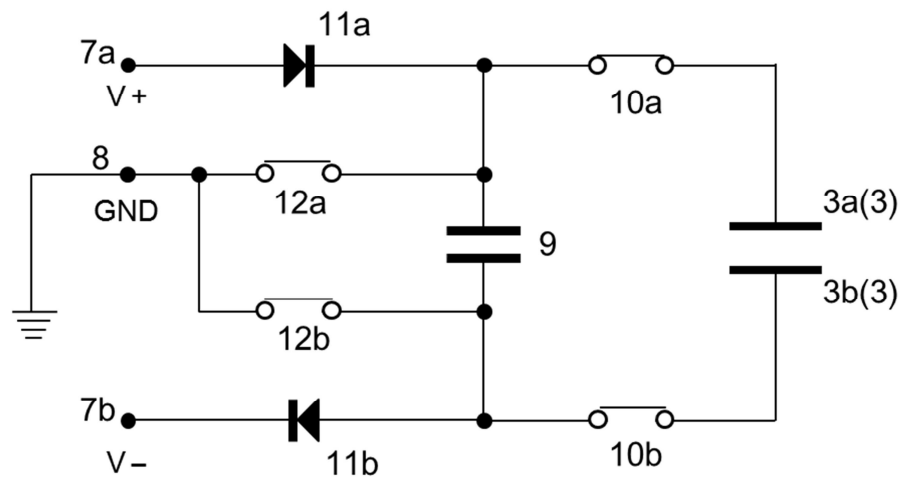


Fig. 8

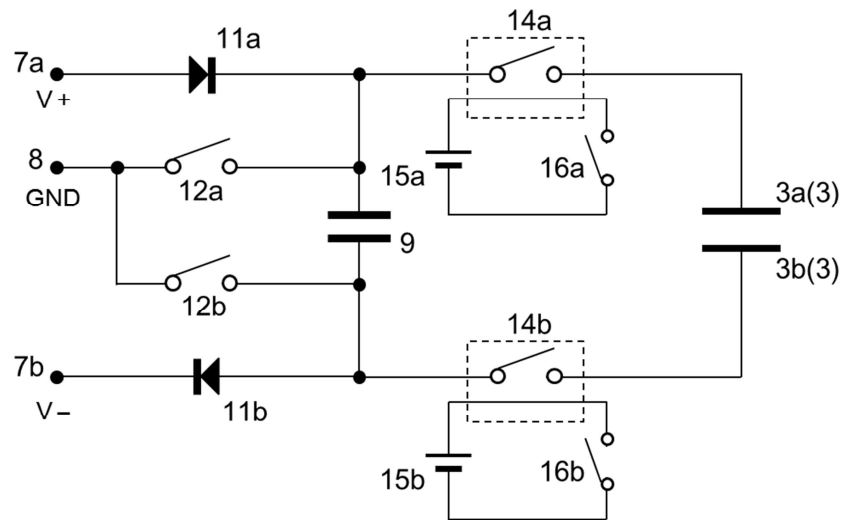


Fig. 9

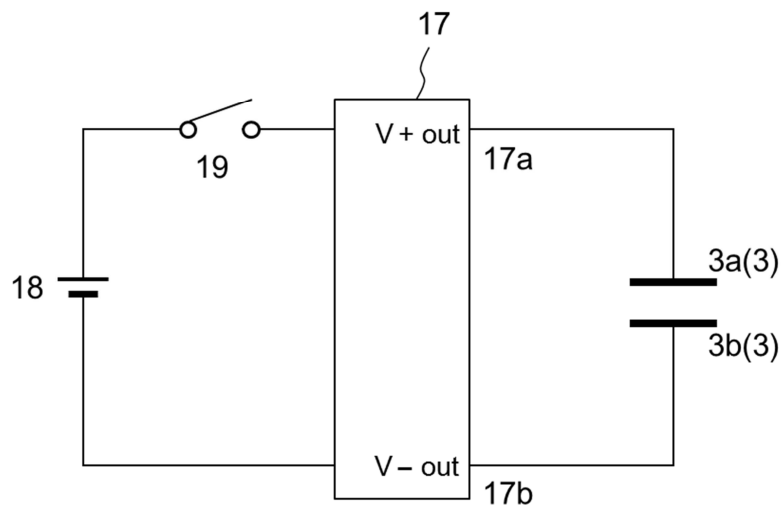


Fig. 10

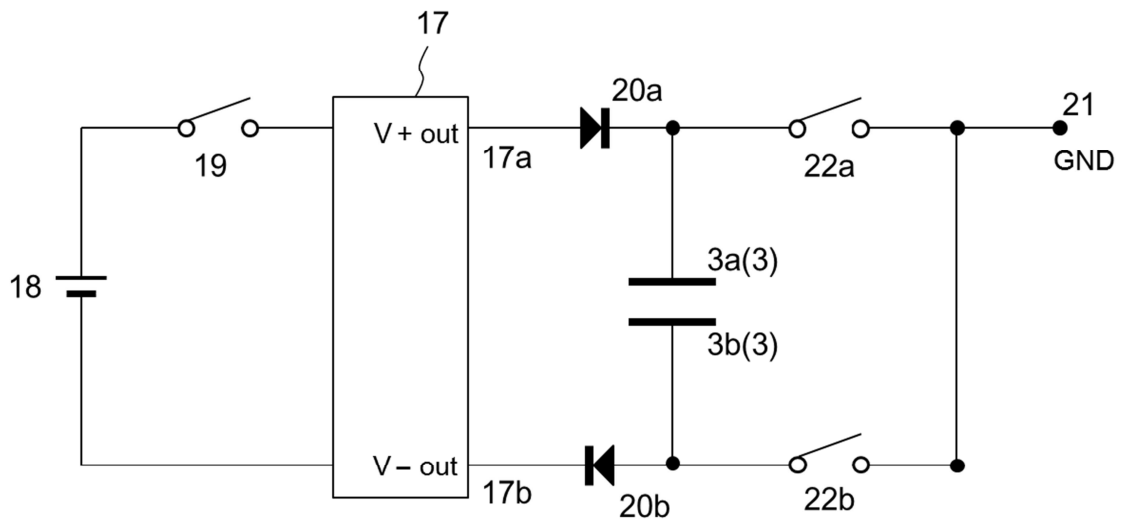


Fig. 11

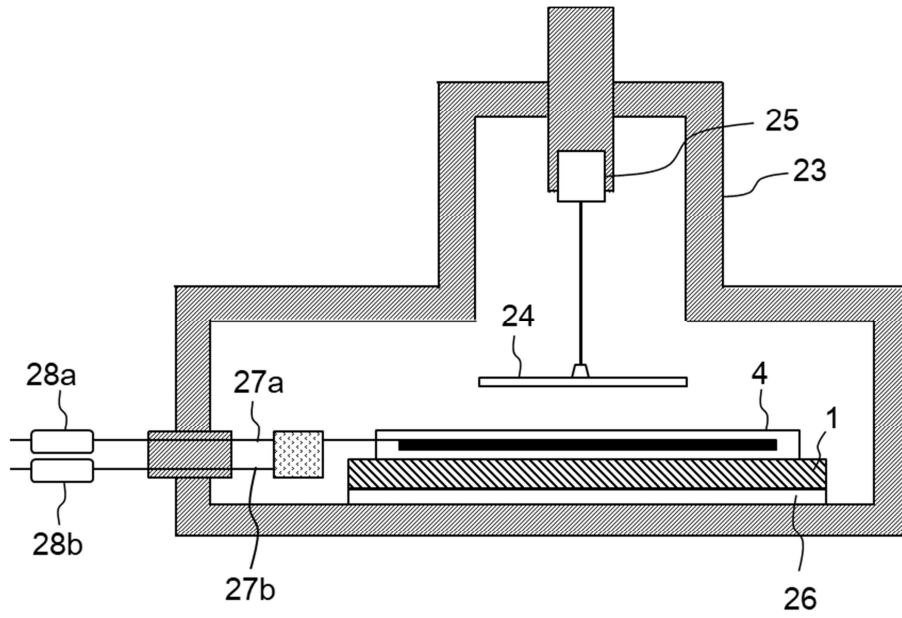


Fig. 12

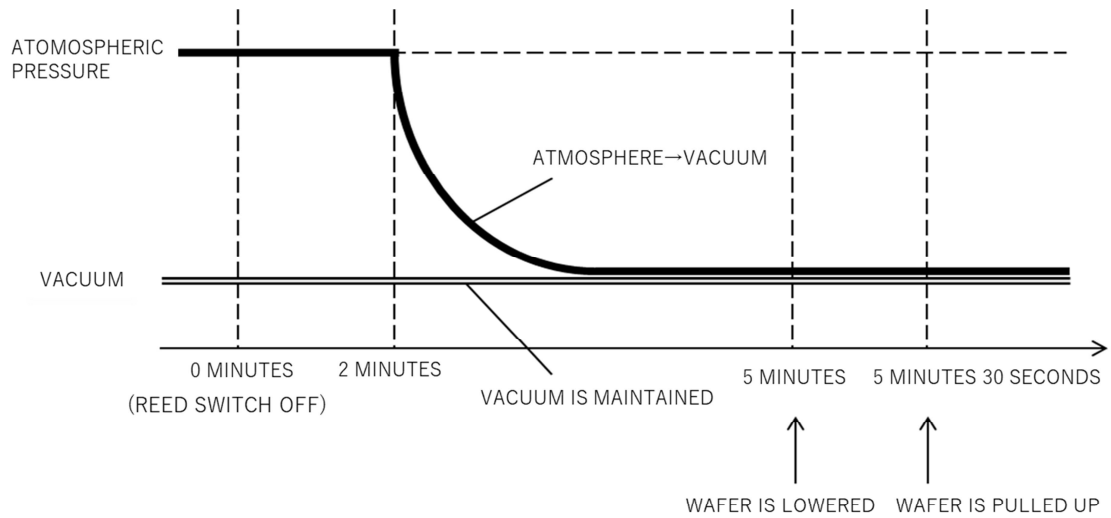


Fig. 13

AVERAGE CLAMPING FORCE OF Si WAFER

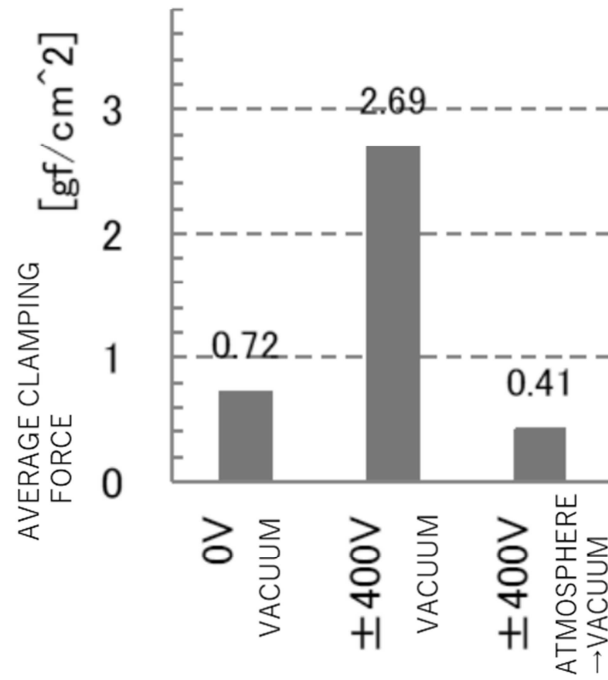


Fig. 14

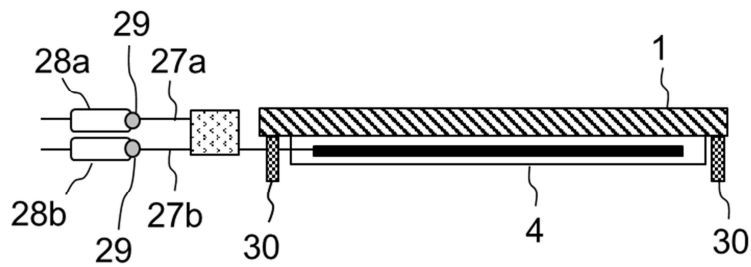


Fig. 15(a)

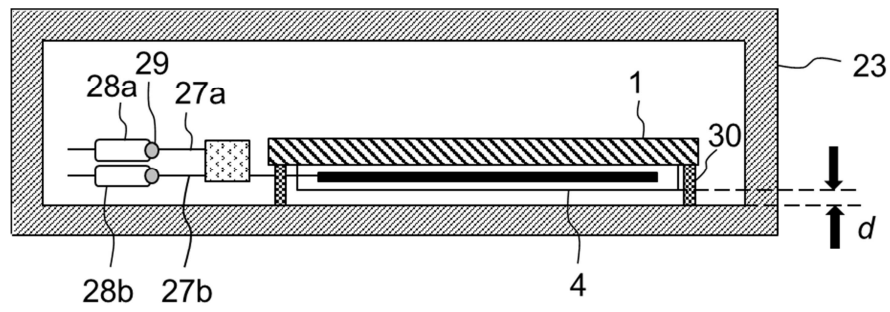


Fig. 15(b)

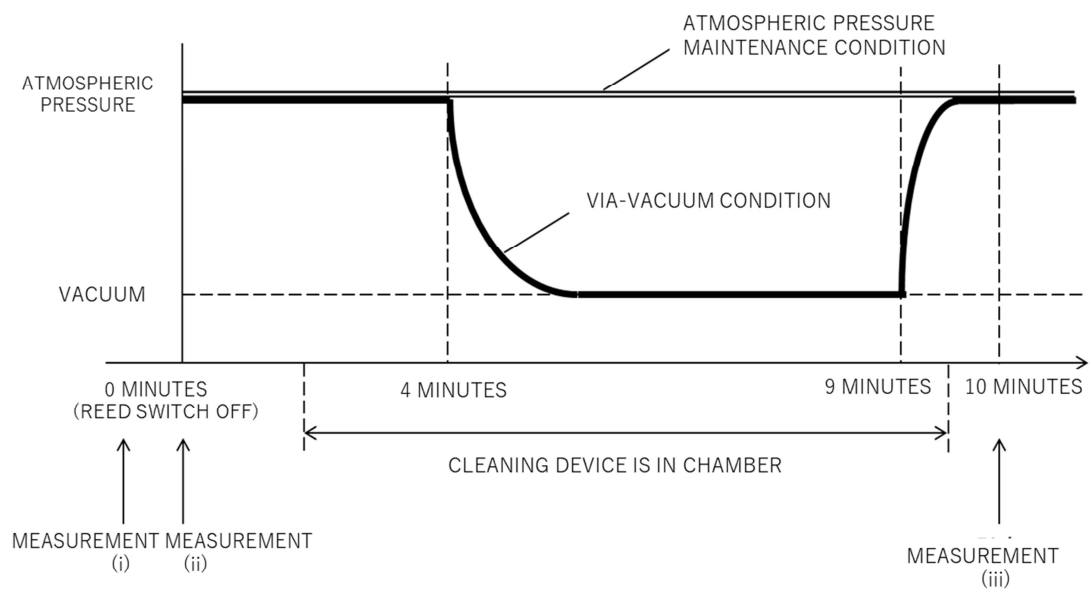


Fig. 16

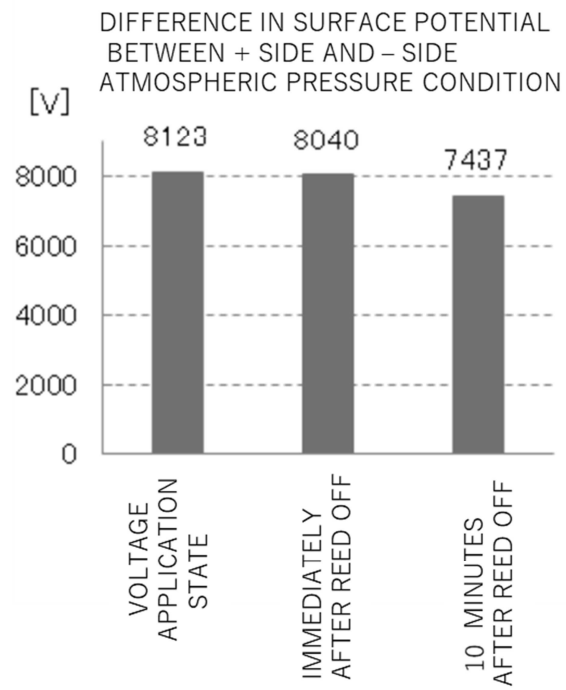


Fig. 17

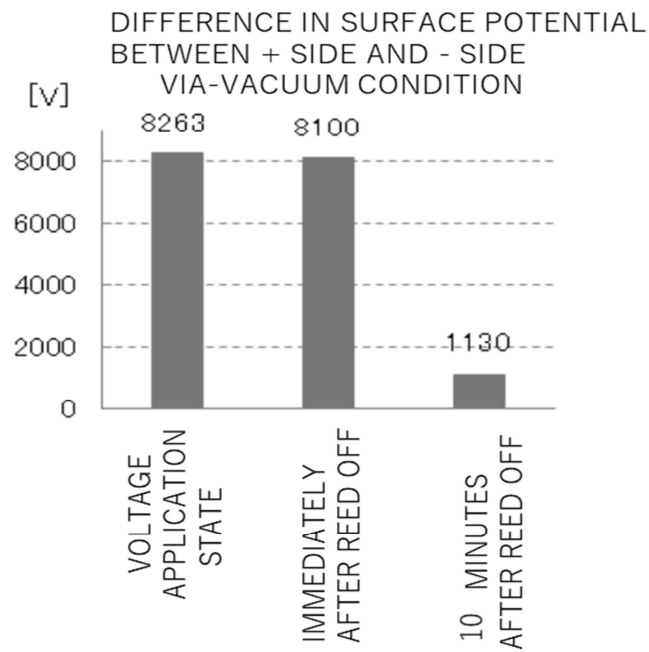


Fig. 18